

Delphi-X Inverso

for materials science

HIGHLIGHTS

- · Materials science applications
- · Observation of materials science samples
- · Brightfield, dark field, polarization
- · DIC (differential interference contrast)
- · Long working distance IOS plan semi apochromatic objectives
- · Revolving sextuple nosepiece
- · 100 W halogen reflected illumination

TECHNICAL SPECIFICATIONS

EYEPIECES

Pair of DIN HWF plan 10x/22 mm

HEAD

- Trinocular 45° inclined tubes
- Interpupillary distance of 47 to 78 mm
- Trinocular head with 100-0, 80/20 and 0/100 positions
- · Built-in Bertrand lens

NOSEPIECE

Revolving sextuple nosepiece on ball-bearings. With DIC slot

OBJECTIVES - 45 MM PARFOCAL

High numerical, infinity (Semi-)apochromatic bright-/darkfield objectives. Long working distance, IOS, no cover glass correction, M26 mount

- Plan Semi-Apochromatic (PL-SAMi): 5x/0.15 WD 20 mm, 10x/0.30 WD 11 mm, 20x/0.45 WD 3.1 mm
- Plan Apochromatic (PL-AMi): 50x/0.80 WD 1 mm and optional 100x/0.90 WD 1 mm

Optional:

EDI-8100: Plan Apochromatic (PL-AMi) 100x/0.90 IOS BD objective,
WD 1 mm, no coverglass correction, 45 mm parfocal, M26 mounting thread
WD = working distance

All optics are anti-fungus treated and anti-reflection coated for maximum light throughput





EDI-2053-PLMI

414.5 (h) x 385 (w) x 627.5 mm (d) | 29 kg

STAGE

Stage 340 x 230 mm, equipped with a coaxial mechanical 130 x 85 mm X-Y stage

Supplied with:

- Metal insert with hole ø 20 mm
- Metal insert with hole ø 28 mm
- Metal insert with drop-shaped hole

Maximum weight for sample: 30 kg

MAGNIFICATION CHANGER

A magnification changer with a 1.5x lens allows intermediary magnifications of 1.5 times the standard objective magnifications. For example, switching from 20x or 50x to 30x to 75x magnification can be done without the need to change objectives

MULTIFUNCTIONAL WHEEL

The Delphi-X Inverso has a 6-position multifunctional wheel, supplied with cubes for two brightfield, one darkfield and one polarization filter. Slider with prisms for the 5x/20x and 50x/100x magnifications and slider with analyzer. See photo 1 next page

Bertrand lens and trino/eyepieces selector



ADDITIONAL SLIDER SLOTS

Besides a field diaphragm and condenser aperture, two slots are available. A slider with two neutral density filters is also supplied. See photo 2

FOCUS ADJUSTMENT

Low positioned coaxial with 10 mm coarse and fine adjustments focusing knobs, 1 μm precision and with friction adjustment

CAMERA PORTS

Beside the standard photo port of the head, there are two other photo parts at both both left and right side of the microscope. See photo 3

ILLUMINATION

Reflected 100 W halogen Intensity adjustable with internal 100-240 V power supply. Fuse holder 1 A / 250 V







MODEL	Trino	LWD Plan Semi-Apo 5/10/20x	LWD Plan Apo 50x	LWD Plan Apo 100x	100 W Halogen illumination	DIC
EDI-2053-PLMI	•	•	•	0	•	o
o = optional						

DELPHI-X INVERSO | v.422331 2/3



ACCESSOIRES

EYEPIECES

Ø 30 mm

EDI-6010 Super wide field SWF 10x/25 mm f ocusable eyepiece for

Delphi-X Inverso

EDI-6010-C Super wide field SWF 10x/25 mm eyepiece

with crosshairs

EDI-6010-M Super wide field SWF 10x/25 mm eyepiece

with micrometer

EDI-6010-CM Super wide field SWF 10x/25 mm eyepiece

with micrometer and crosshairs

EDI-6010-SG Super wide field SWF 10x/25 mm eyepiece

with 20 x 20 square grid reticle

EDI-6210 Super wide field SWF 10x/22 mm focusable eyepiece for

Delphi-X Inverso

EDI-6012 Wide field WF 12.5x/17.5 mm eyepiece

for Ø 30 mm tube for Delphi-X Inverso

EDI-6015 Wide field WF 15x/16 mm eyepiece

for Ø 30 mm tube for Delphi-X Inverso

EDI-6020 Wide field WF 20x/12 mm eyepiece

for Ø 30 mm tube for Delphi-X Inverso

EDI-6099-L Eyeshade for eyepieces

OBJECTIVES 45 MM PARFOCAL

M26 mounting thread, no cover glass correction

FDI-8105 Infinity Plan Semi-Apochromatic PL-SAMi 5x/0.15 IOS BD

objective, working distance 20 mm

EDI-8110 Infinity Plan Semi-Apochromatic PL-SAMi 10x/0.30 IOS BD

objective, working distance 11 mm

EDI-8120 Infinity Plan Semi-Apochromatic PL-SAMi 20x/0.40 IOS BD

objective, working distance 3.1 mm

EDI-8150 Infinity Plan Apochromatic PL-AMi 50x/0.80 IOS BD objective,

working distance 1 mm

EDI-8100 Infinity Plan Apochromatic PL-AMi 100x/0.90 IOS BD objective,

working distance 1 mm

BD = brightfield/darkfield

DIFFERENTIAL INTERFERENCE CONTRAST (DIC)

EDI-9691-52 DIC prism for nosepiece of materials science Delphi Inverso model. To be used with Plan Semi-Apochromatic 5x/20x

objectives

EDI-9691-51 DIC prism for nosepiece of materials science Delphi Inverso

models. To be used with Plan Apochromatic 50x/100x

objectives

EDI-9698 DIC analyzer for nosepiece for Delphi-X Inverso

MISCELLANEOUS

EDI-9810 C-mount with 1x magnification for 1 or 2/3 inch C-mount

camera

EDI-9840 C-mount with 0,4x magnification for 1/3 inch C-mount camera

EDI-9850 C-mount with 0,5x magnification for 1/2 inch C-mount camera







EDI-6210 EDI-9840















